

ABSTRACT OF THE DISCLOSURE

TITLE OF INVENTION: FILM, METHOD FOR FORMING PROTRUDED
PORTIONS OF PLASMA DISPLAY USING THE
SAME, AND PLASMA DISPLAY FABRICATED
BY THE METHOD

The method for forming partition walls of a
plasma display is a method for forming partition walls on
a rear side substrate used for a plasma display, wherein an
5 insulating photosensitive resin film obtained by developing
into a filmy form a resin composition containing at least
a glass powder, organic high polymer binder, photoreaction
initiator, and photoreaction accelerator is placed on the
rear side substrate, and the film placed on the rear side
10 substrate is exposed to light and developed by using a mask
with a desired pattern, so that protruded portions that
will form the partition walls of a desired configuration
are formed. With this method, since the components within
the film are fixed in state, unlikely to be fluidized,
15 protruded portions of the most possible uniformity and of
a desired configuration can be formed with high precision
only by exposing the film to light via a mask corresponding
to the desired configuration.

Figure 6.